

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/520,680	<b>Applicant(s)/Patent under Reexamination</b> SHIDA, ZENICHIROU
	<b>Examiner</b> Steven D. Maki	<b>Art Unit</b> 1733

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner